


Search Notes 	Application/Control No. 10580698	Applicant(s)/Patent Under Reexamination FIOLKA ET AL.
	Examiner Jade R. Chwasz	Art Unit 2872

SEARCHED			
Class	Subclass	Date	Examiner
359	489	11/5/08	JRC

SEARCH NOTES		
Search Notes	Date	Examiner
Inventor name search	11/5/08	JRC
Information disclosure statement review	11/5/08	JRC
359/483,485,487,488,489,494-497,500,501 with text in EAST	11/5/08	JRC
Text search in EAST	11/5/08	JRC
Consulted with Primary Arnel Lavarias	11/13/08	JRC
Updated search	3/16/09	JRC
Consulted with Primary Arnel Lavarias	3/30/09	JRC
Updated search	6/9/09	JRC
Information disclosure statement review	6/9/09	JRC
Consulted with Primary Arnel Lavarias	6/10/09	JRC
Updated search	11/2/09	JRC
Consulted with Primary Arnel Lavarias	11/2/09	JRC
Information disclosure statement review	1/20/10	JRC
Consulted with Primary Arnel Lavarias	1/20/10	JRC
Information disclosure statement review	3/24/10	JRC
Consulted with Primary Arnel Lavarias	3/24/10	JRC
Information disclosure statement review	4/23/10	JRC
Consulted with Primary Arnel Lavarias	4/23/10	JRC
Information disclosure statement review	6/24/10	JRC
Consulted with Primary Arnel Lavarias	6/24/10	JRC
Information disclosure statement review	8/23/10	JRC
Consulted with Primary Arnel Lavarias	8/23/10	JRC
Information disclosure statement review	11/1/10	JRC
Consulted with Primary Arnel Lavarias	11/1/10	JRC
Information disclosure statement review	12/15/10	JRC
Consulted with Primary Arnel Lavarias	12/15/10	JRC
Updated search in EAST	2/22/11	JRC
Information disclosure statement review	2/22/11	JRC
Consulted with Primary Arnel Lavarias	2/22/11	JRC
Updated search in EAST	6/9/11	JRC
Information disclosure statement review	6/9/11	JRC

--	--

SEARCH NOTES		
Search Notes	Date	Examiner
Consulted with Primary Arnel Lavarias	6/13/11	JRC

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
	Interference search (see attached)	3/19/09	JRC
	Interference search (see attached)	11/2/09	JRC